1005 Bowers Avenue \$405 Carta Clara: California 95051 (40%) 987-8080

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SFUND RECORDS CTR 2807-91367

SFUND RECORDS CTR
88171542

October 13, 1983



Mr. Russ Frazer Engineering Assistant, Water Division City of Mountain View 231 N. Whisman Rd. Mountain View, CA 94040

Dear Sir,

Intel discontinued the use of the Intel Mountain View facility as a fabrication plant in December, 1980. Until recently, the building has remained vacant.

In June, 1983, Intel began using the building as a test facility for semiconductors. This type of operation does not involve significant chemical usage.

By November, 1983, Intel plans to start a wafer sort operation at this facility. This operation requires the cleaning of silicon wafers with M-PYROL (as a degreasing agent) and subsequent rinsing.

The M-PYROL baths will be disposed of via 55 gallon steel drums. The carry-over of M-PYROL on the wafers will result in small amounts of M-PYROL being rinsed down a sanitary drain.

Intel is requesting an Industrial Waste Discharge Permit for this one operation.

Thank you for your time and consideration in this matter. If you have any comments or questions, please contact this office at (408) 937-6998.

Sincerely,

Bryan M. Rector

California Facilities Engineering

Environmental Specialist

cc: B. Sherman

M. Chang

N. Lougee - City of Mountain View

CITY OF MOUNTAIN VIEW

APPLICATION FOR INDUSTRIAL WASTES DISCHARGE PERMIT

(408) 987-6998 (415) 969-1838 Telephone * ment Facility eak Hourly <10GP
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x. Conc. Allowable Ma lowable Emission Rat mg/l kg/day

MD-6A (1-83) DIST: Original - File: Copy - Discharger: Copy - Water Quality Control Plant

INTEL INDUSTRIAL WASTE DISCHARGE PERMIT

ATTACHMENT 1

C.

- 1. The industry is semiconductor, SIC #3674.
- 2. M-PYROL (N-Methylpyrrolidone). See attached Material Safety Data Sheets.
- 3. The previous acid neutralization system was removed from this site in December 1981; therefore, there is no waste treatment system for this waste stream.
- 4. See attached Material Safety Data Sheets and the GAF Corporation specifications.
- 5. Not applicable.
- 6. N-Methylpyrrolidone (M-PYROL). The estimated volume of M-PYROL that will be rinsed down the sanitary drain is:

7000 wafers/month ÷ 30 wafers/BOAT X 10 ML M-PYROL/BOAT

- = 2333 m1/mo. = 0.62 gal. M-PYROL/14,000 Gal. water = 44.3PPM*
- * Once operations start grab/composite sampling will be started to confirm this estimate.

No other chemicals are expected in this waste water stream.

